

MEMS Scanning Micro-Mirror

1. Key Specifications

- Single or dual axis tilting
- Mirror size: $\varnothing 0.8$, $\varnothing 1.0$, $\varnothing 2.0$, $\varnothing 2.5$, $\varnothing 3.5$ mm in diameter
- Max. tilt angle range: X +/-10 deg., Y +/-10 deg.
- Electrostatic actuation (resonating actuation); visually zero power consumption

2. Specifications

Parameters	Conditions	Unit	Specifications		
			Min	Typical	Max
Mirror Diameter	Circular (or effective)	mm		$\varnothing 0.8$, $\varnothing 1.0$, $\varnothing 2.0$, $\varnothing 2.5$, $\varnothing 3.5$	
Mirror Flatness	ROC	m	0.8	1	5
Reflectivity (Al or Au reflector)	1260-1660 nm	%	96		99
Power Handling		mW			500
Damage Voltage	X and Y axes	V	70		180
Actuation Voltage	X axis, at room temp.	V	30		170
	Y axis, at room temp.	V	30		170
Max Tilt Angle	X	deg.	+/- 2.5		+/- 10
	Y	deg.	+/- 2.2		+/- 10
Resonant Frequency	X	Hz	300		6,000
	Y	Hz	300		2,100
Response Time	From neutral to max tilt angle using a step function input	ms			1
Temperature Stability	Over -5 to 75 °C	deg.			0.001
Durability	Hermetically vacuum sealed	Cycle		10 ⁹	
Operating Temperature		°C	-5		75
Storage Temperature Range	5% humidity	°C	-40		85
Baking Temperature	Less than 3h	°C			110
Wire Bond Temperature	Less than 5min	°C			150